Low Voltage Electron Beam Lithography By Weidong Liu

By Weidong Liu

Low-Voltage Spatial-Phase-Locked Scanning-Electron-Beam Lithography by Lin Lee Cheong Submitted to the Department of Electrical Engineering and Computer Science on April
http://dspace.mit.edu/bitstream/handle/1721.1/60159/681751108-MIT.pdf?sequence=2
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Novel micro-objective lens for low voltage electron beam imaging. Author/Creator Liu, Weidong Language English. Imprint 1998. Physical description xv, 128 leaves, bound.
http://searchworks.stanford.edu/view/4000265

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http://spie.org/Publications/Proceedings/Paper/10.1117/12.656496

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We present electron-beam-induced oxidation of single- and bilayer graphene devices in a low-voltage standard electron-beam lithography P. Liu, F. Arai, T
http://www.sciencedirect.com/science/article/pii/S0008622313006726

An electron beam system provides low aberration, The retarding electrode decreases the energies of the primary beam 22! from 10 keV to less than 100 eV,
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Charge induced pattern distortions in low voltage electron beam lithography in the energy range of electron. Eng. 35, 165 ~1997!. 12W. Liu, J. Ingino,
http://pages.pomona.edu/~dmt04747/Pubs/ChargeDistort.pdf

Novel objective lens for low voltage electron beam imaging Buy: USD28.00. 10.1116/1.589718. W. Liu 1, M. McCord 1 and R. F . Pease 1. View and lithography.
http://scitation.aip.org/content/avs/journal/jvstb/15/6/10.1116/1.589718

Lothar Bauch; Monika Boettcher; Ulrich Haak and Ulrich A. Jagdhold "Low-voltage electron-beam lithography linked to photolithography", Proc. SPIE 2437, Electron-Beam
http://proceedings.spiedigitallibrary.org/proceeding.aspx?articleid=994799

Low voltage electron beam lithography in PMMA Mehdi Bolorizadeha, David C. Joya, b aEM Facility, University of Tennessee, Knoxville, TN 37996 bOak Ridge National
http://www.nsti.org/publications/Nanotech/2005/pdf/1018.pdf

Electron Specimen Interaction In Low Voltage Electron Beam Lithography Weidong Liu July 1995
http://www.dtic.mil/cgi-bin/GetTRDoc?AD=ADA327202

A novel curve-fitting procedure for determining proximity effect Chun-Hung Liu, Effects of fast secondary electrons to low-voltage electron beam lithography.
http://proceedings.spiedigitallibrary.org/proceeding.aspx?articleid=1330405

200 nm gate-length GaAs-based MHEMT devices by electron beam lithography HaiYing Zhang, WenXin Wang, Liang Liu , et al. A Low-Voltage 77
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http://spie.org/Publications/Proceedings/Paper/10.1117/12.707374

Enden D. Liu; Cong Tran; Effects of fast secondary electrons to low-voltage electron beam lithography. J. Micro/Nanolithography, MEMS, and MOEMS (April 1, 2007)
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